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PTO/SB/08a (08-03)

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Sheet 1 of 9

Application Number	09/965,370
Filing Date	September 26, 2001
First Named Inventor	Chung, et al.
Group Art Unit	1762
Examiner Name	Eric B. Fuller
Attorney Docket Number	AMAT/6303/CPI/COPPER/PJS
Submission Date	August 27, 2004

U.S. PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code ² (if known)			
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	A2	US-6660660 B2	12/09/2003	Haukka, et al.	
	A3	US-6632279 B1	10/14/2003	Ritala, et al.	
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Sheet 2

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Group Art Unit

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Application Number	09/965,370
Filing Date	September 26, 2001
First Named Inventor	Chung, et al.
Group Art Unit	1762
Examiner Name	Eric B. Fuller
Attorney Docket Number	AMAT/6303/CPI/COPPER/PJS
Submission Date	August 27, 2004

U.S. PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code ² (if known)			
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Group Art Unit

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